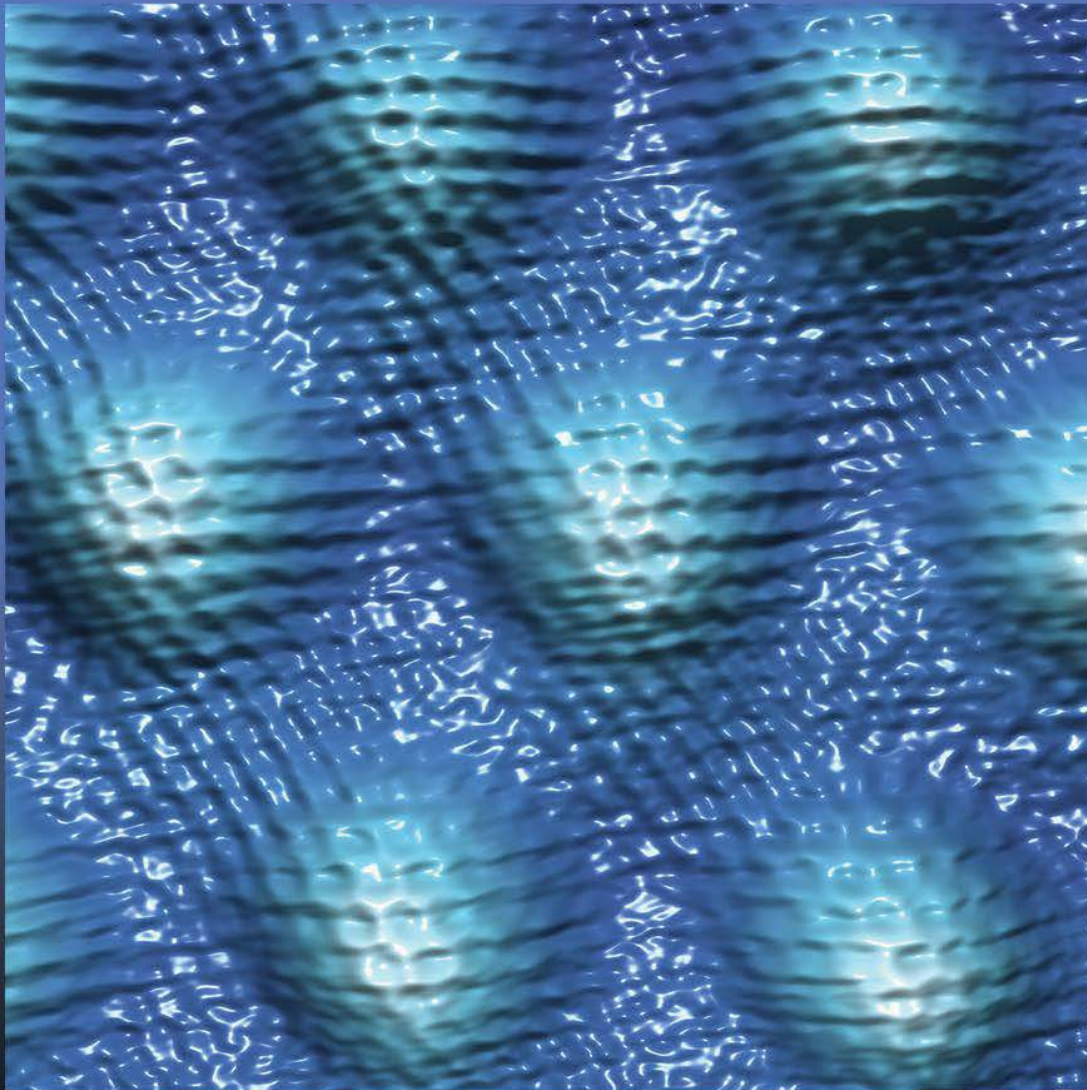


# JVSTA

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*Image Credit: Joshua Wagner and Steven J. Silberer, JVST A 43 (6), 10.1116/6.0004964, (2025).*

## **Review Article:**

Artificial intelligence in atomic layer deposition

Pouyan Navabi, Remya Ampadi Ramachandran, Harshdeep Bhatia, Majid Jabeiri-Douraki, Urmila Diwekar, Cortino Sukotjo, and Christos G. Takoudis



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